# **ssdm** 2014

# **Epitaxial Graphene Devices for Scanning Probe Measurements**

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## Funding











# Outline

## Introduction

Dissipationless currentGraphene on SiC

**Goal** •Scanning Gate Microscopy

### Mono- and bilayer composite devices in the Quantum Hall regime

Device configuration
Raman map & atomic force microscopy image
Transport measurements
Conductance calculation

### Summary

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# Introduction

### **Dissipationless current**

Edge current flows in quantum Hall regime Controlling dissipationless current

### Why graphene?

Clear quantum Hall effect is observed
High mobility
Filling factor differs between mono- and bilayer graphenes



future low-energy



# 

 $V_{\alpha}(V)$ 

#### **Graphene on SiC**

Epitaxial growth by Si sublimation technique large area, high quality, insulating substrate

A. K. Geim and K. S. Novoselov, Nature Mater. 6, 183 (2007)
K. S. Novoselov et al., Nature 438, 197 (2005)
Y. Zhang et al., Nature 438, 201 (2005)
Hiroki Hibino et al., NTT Technical Review 8,(2010)

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# Goal: Scanning Gate Microscopy

A voltage-biased AFM tip is scanned above a sample surface. This creates a perturbation below the tip, which locally modifies the potential landscape of a device (typically 2DEGs, graphene, nanowires).

Scanning Gate Microscopy: low-T, high-B AFM Topographic imaging + movable electrostatic gate

**2D imaging of transport properties** 

### Space information: G(x,y)

Extension / space distribution of electronic states Relevant length scales (inter-channel relaxation length) Size-dependent effects (edge state mixing)

resolution	≤ 10 nm
stability	months
temperature	300 mK
Magnetic field	0-9 T





Side-gate structure



Tip voltage is applied at the center

M. A. Topinka et al., Nature 410 (2001).R. Crook et al., Science, 312 (2006).N. Paradiso et al., Phys. Rev. Lett., 108 (2012).

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...

# Fabrication: Side-Gated Devices

•Epitaxial graphene grown on the Si face of SiC (0001).

•Large area Hall bars (300 μm x 50 μm)

•Gate insulator: HSQ (Hydrogen Silsequioxane) (140 nm) + SiO<sub>2</sub> (40 nm)

•Electrode: Cr/Au (10/180 nm)



S. Tanabe, Y. Sekine, H. Kageshima, M. Nagase, and H. Hibino, Phys. Rev. B 84, 115458 (2011).

### First Step

Characterization of the electric properties of the device without applying the side-gate voltage and AFM tip voltage

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# Sample: AFM & Raman







~ few μm wide monolayer regions on SiC terraces

≤1 µm wide bilayer domains along step edges

#### Raman spectra @ Room Temperature

(Renishaw Micro-Raman)
 514 nm laser excitation
 spot diameter < 1 μm.</li>
 50 μm
 step-size of 0.5 μm
 integration times up to 10 s (low noise)

<u>Monolayer</u>: single Lorentzian → 2680-2720 cm<sup>-1</sup> <u>Bilayer</u>: 4 Lorentzians → 2720-2760 cm<sup>-1</sup>



The Hall bar is intersected by tens of SiC step edges, onto which elongated bilayer domains are present.

 $\rightarrow$  Bilayer stripe connect one side of the device to the other

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# Configuration of mono- and bilayers

From the experimental results of magnetoresistance

## Bilayer stripe (red) crossing Hall bar



longitudinal resistance R<sub>xx</sub>: R<sub>1-3</sub>, R<sub>4-6</sub>

transverse resistance R<sub>xv</sub>: R<sub>1-4</sub>, R<sub>3-6</sub>

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# Magnetoresistance (1): Low Magnetic Field

@ 250 mK



|B| < 5 T</th>Conventional quantum Hall effect of<br/>monolayer graphene

longitudinal resistance Rxx: similar at both device sides; typical behavior expected for clean monolayer: weak localization around B=0; magneto-oscillations (precursory to the Shubnikov-de Haas).



transverse resistance Rxy: similar for both contact pairs; monotonous dependence; v=6 plateau.



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# Magnetoresistance (2): High Magnetic Field



Bilayer stripe (red) crossing Hall bar





|B| > 5 T

## Anomalous Quantum Hall effect

#### **longitudinal resistance Rxx:**

- 1-3 : <u>invariant</u> to inversion of B;  $\mathbf{R} \approx \mathbf{10} \ \mathbf{k} \Omega$
- 4-6 : asymmetric upon inversion of B ; SdH for B<0 only

#### transverse resistance Rxy:

3-6 : conventional (**symmetric**) half-integer QHE; v= $\pm 2$  plateaus 1-4 : **asymmetric** upon inversion of B ; R<sub>1-4</sub>=-1.6 k $\Omega$  for B<0



- L. <u>B-dependent effect</u>
- 2. Flat resistance values
- 3. Peculiar asymmetry

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# Configuration of mono- and bilayers



# Landauer-Büttiker approach



 $|v_{\rm B}| > |v_{\rm M}|, v_{\rm B} \cdot v_{\rm M} > 0$ 

Mixing of channel
Current conservation at boundary between monoand bilayer graphene



$$I_{\rm S} = I, I_{\rm D} = -I, I_{\rm i} = 0$$

*I*<sub>i</sub> : current

- $r_{ii}$ : total reflection coefficient at electrode i
  - (r<sub>ii</sub> = 0 for ideal lead)
- $\mu_{\rm i}$  : electrochemical potential
- $T_{ij}$ : total transmission coefficient from i to j electrodes (probability ejected into vproportional to 1/v for each electron)



$$R_{1-3}$$
  $R_{4-6}$   $R_{1-4}$   $R_{3-6}$ 

$$B>0 (CW) \frac{\nu_B - \nu_M}{\nu_B \nu_M} \frac{\nu_B - \nu_M}{\nu_B \nu_M} \frac{1}{\nu_M} \frac{1}{\nu_M}$$
$$B<0 (CCW) \frac{\nu_B - \nu_M}{\nu_B \nu_M} 0 - \frac{1}{\nu_B} - \frac{1}{\nu_M}$$

### in a unit of $h/e^2$

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# Summary

Hall bar oriented perpendicularly to the SiC(0001) step edges:

We observe an asymmetric B-dependence of the magnetoresistance due to the continuous bilayer stripe crossing the device.

❑ We propose a **quantitative model** involving the simultaneous coexistence of quantum Hall conditions in the monolayer and bilayer regions, at **different filling factors**, which fully account for the asymmetry and the observed quantized resistance values.

The transport channels in the bilayer are responsible for mixing of the edge channels in the monolayer and deviations from the conventional quantum Hall effect.

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# Motivation: Graphene

### Why graphene?

Unique Electronic Properties: Relativistic carriers, Klein tunneling, snake states... Unique Conformational Properties: Single atom layer, exposed surface



#### Ways to make graphene

- exfoliation from graphite (small)
- chemical vapor deposition (large, conductive substrate)
- epitaxial growth on SiC (large, wide-gap substrate)

A. K. Geim and K. S. Novoselov, Nature Mater. 6, 183 (2007)
K. S. Novoselov et al., Nature 438, 197 (2005)
Y. Zhang et al., Nature 438, 201 (2005)
Hiroki Hibino et al., NTT Technical Review 8,(2010)



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# Device for low magnetic field



Tunable carrier density (and mobility)  $n = -2 \times 10^{10}$  to  $4 \times 10^{11}$  cm<sup>-2</sup>  $\mu = 0 - 35000$  cm<sup>2</sup>/Vs

Monolayer graphene (i.e., half-integer quantum Hall effect)





#### Dominant effect depends on carrier density



A. lagallo, S. Tanabe, S. Roddaro, M. Takamura, H. Hibino, and S. Heun, Phys. Rev. B 88, 235406 (2013)

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A. Iagallo, S. Tanabe, S. Roddaro, M. Takamura, H. Hibino, and S. Heun, Phys. Rev. B 88, 235406 (2013)

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A. A. Kozikov et al., Phys. Rev. B 82, 075424 (2010).
J. Jobst et al., Phys. Rev. Lett. 108, 106601 (2012).
S. Lara-Avila et al., Phys. Rev. Lett. 107, 166602 (2011)



Linear slope → Electrons in disordered graphene behaves as a **Fermi liquid**.

Clear <u>**n-dependence of K**</u><sub>ee</sub> at low density, not accounted for by present theory (dielectric environment? charge inhomogeneity around CNP?)

A. lagallo, S. Tanabe, S. Roddaro, M. Takamura, H. Hibino, and S. Heun, Phys. Rev. B 88, 235406 (2013)

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# Quantum Interference/01

After subtracting EEI contribution

$$\frac{\Delta R_{xx}}{R_0^2} = -\frac{e^2}{\pi h} \left[ F\left(\frac{\tau_B^{-1}}{\tau_{\varphi}^{-1}}\right) - F\left(\frac{\tau_B^{-1}}{\tau_{\varphi}^{-1} + 2\tau_{iv}^{-1}}\right) - 2F\left(\frac{\tau_B^{-1}}{\tau_{\varphi}^{-1} + \tau_*^{-1}}\right) \right]$$



E. McCann et al., Phys. Rev. Lett. 97, 146805 (2006)

 $F(z) = \ln(z) + \psi(0.5 + z^{-1}), \quad \psi(x) \text{ is the digamma function}$   $\tau_{\varphi} = \text{dephasing time}$   $\tau_{w} = \text{inter - valley scattering}$   $\tau_{e} = \text{intra - valley scattering}$   $\psi(x) \text{ is the digamma function}$  $\tau_{e} = \frac{4DeB}{\hbar}, D = \text{diffusion coefficient}$ 



A. lagallo, S. Tanabe, S. Roddaro, M. Takamura, H. Hibino, and S. Heun, Phys. Rev. B 88, 235406 (2013)

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# Quantum Interference/02

**Dephasing time**  $\tau_{\phi}$ : Saturation in T; Constant in n.

Intervalley scattering time τ<sub>iv</sub>: Almost constant in T; Small variation with n. Intravalley scattering

**time τ<sub>\*</sub>:** Small variation in T; Large variation with n.







A. lagallo, S. Tanabe, S. Roddaro, M. Takamura, H. Hibino, and S. Heun, Phys. Rev. B 88, 235406 (2013)

<u>τ<sub>\*</sub>: unexpected density dependence</u>

The observed dependence is larger

than the sole trigonal warping

trigonal warping gives  $\sim n^{-2}$ 

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# Low magnetic field summary



- □ We presented a **systematic** analysis of magnetotransport properties in epitaxial graphene grown on the Si-terminated face of SiC.
- We describe **EEI** in graphene with the current theory for disordered systems, and we find an **unexpected dependence of the interaction parameter** K<sub>ee</sub> **on** <u>carrier density</u>.
- □ Fitting the **quantum interference** correction, we find that the dephasing and intervalley times are almost constant, while the **intravalley scattering time shows a peculiar dependence on density**, different from the sole warping term.
- Our results stress the **role of charge density** in determining quantum interference and EEI, and the necessity of further investigation of its impact **on the low-field magnetoresistance** of graphene devices.

A. Iagallo, S. Tanabe, S. Roddaro, M. Takamura, H. Hibino, and S. Heun, Phys. Rev. B 88, 235406 (2013)

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## Thank you for your attention

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